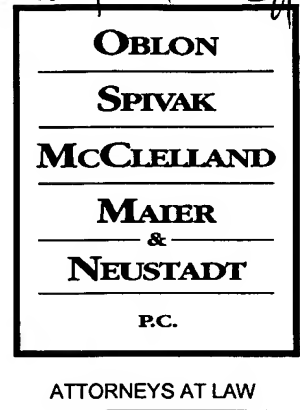




Docket No.: 260055US26SP PCT



COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/509,338

Applicants: Takehiro UEDA, et al.

Filing Date: October 8, 2004

For: METHOD FOR SUPPRESSING CHARGING OF
COMPONENT IN VACUUM PROCESSING
CHAMBER OF PLASMA PROCESSOR AND
PLASMA PROCESSOR

Group Art Unit: 1765

Examiner: DAHIMENE, M.

SIR:

Attached hereto for filing are the following papers:

**REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.111 and REQUEST FOR
EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Our credit card payment form in the amount of \$450.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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